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Total Number of Pages: 02

B.Tech
BSCP1207

3rd Semester Back Examination 2016-17
PHYSICS OF SEMICONDUCTOR DEVICES

BRANCH(S): BIOTECH,EE, EEE

Time: 3 Hours

Max Marks: 70

Q.CODE: Y601

Answer Question No.1 which is compulsory and any five from the rest.
The figures in the right hand margin indicate marks.

Q1 Answer the following questions: (2 x 10)

- What is latch-up in CMOS circuits?
- What is effective mass? Write the expression for it.
- What do you mean by punch-through breakdown?
- What is steep-retrograde body doping? Mention its advantages over the normal body doping.
- Distinguish between Schottky barrier diode and Ohmic contact.
- Sketch the curve showing the variation of Fermi-level (E_F) with doping concentration & absolute temperature for both n-type and p-type semiconductors.
- Determine the total number of energy states in Si between E_C to $E_C + K_B T$ at $T = 300K$, where K_B is Boltzmann's constant, (Given that electron effective mass of GaAs, $m_n^* = 1.08m_0$ and Planck's constant, $h = 6.6 \times 10^{-34}Js$.)
- Calculate the temperature at which there is a 10^{-3} probability that an energy state 0.53 eV above Fermi energy level is occupied by an electron.
- What is the significance of Fermi energy level? Under what condition, Fermi Dirac distribution function changes to Boltzmann distribution?
- Distinguish between degenerate and non-degenerate semiconductor.

Q2

- Derive an expression for the thermal equilibrium concentration of electrons⁰ in the conduction band using⁰ density of states function and Fermi-Dirac distribution function. **(5)**
- Calculate the intrinsic carrier concentration in GaAs at $T = 400K$. Given that $N_c = 4.7 \times 10^{17} cm^{-3}$; $N_v = 7 \times 10^{18} cm^{-3}$ at $T = 300K$. $E_g = 1.42eV$. **(5)**

Q3

- Derive an expression for the diode current in an ideal Schottky barrier diode and describe its I-V characteristics. **(5)**

- b) Calculate the theoretical barrier height, built-in potential barrier and maximum electric field in a metal-semiconductor diode between tungsten and n-type silicon doped to $N_d = 10^{16} \text{ cm}^{-3}$ at $T = 300\text{K}$ for zero applied bias if work function of metal is $\phi_m = 4.55 \text{ V}$ and electron affinity of the semiconductor is $\chi = 4.01 \text{ V}$. Given $n_i = 1.5 \times 10^{10} \text{ cm}^{-3}$, $\epsilon_s = 11.7\epsilon_0$ with $\epsilon_0 = 8.85 \times 10^{-14} \text{ C}^2 \text{ N}^{-1} \text{ cm}^{-2}$. (5)

Q4

- a) Derive the expression for excess minority carrier electron concentration in the base region for the forward active mode of an npn BJT. (5)
- b) Using Ebers-Moll model of a bipolar transistor, derive the expressions for emitter and collector currents with necessary equivalent circuit diagram. (5)

Q5

- a) Derive an expression for built-in potential barrier of a uniformly doped abrupt pn junction in thermal equilibrium with necessary energy band diagram. (5)
- b) For a Si pn junction, at $T = 300\text{K}$ with zero applied bias has doping concentrations of $N_d = 6 \times 10^{16} \text{ cm}^{-3}$ and $N_a = 4.5 \times 10^{15} \text{ cm}^{-3}$. Determine x_n, x_p and space charge width W . Given $n_i = 1.5 \times 10^{10} \text{ cm}^{-3}$, $\epsilon_s = 11.7\epsilon_0$ with $\epsilon_0 = 8.85 \times 10^{-14} \text{ C}^2 \text{ N}^{-1} \text{ cm}^{-2}$. (5)

Q6

- a) What is threshold inversion in a MOS capacitor? Derive the expression for threshold voltage of a MOS capacitor with p – type semiconductor substrate. Express it in terms of Flat-band voltage. (5)
- b) An MOS device has the parameters; aluminum gate, p-type substrate with $N_a = 3 \times 10^{16} \text{ cm}^{-3}$, $t_{ox} = 500 \text{ \AA}$ and $Q_{ss}' = 10^{11} \text{ eCoulomb} \cdot \text{ cm}^{-2}$ and $\phi_{ms} = -0.981$. Determine the threshold voltage at $T = 300 \text{ K}$ if, $n_i = 1.5 \times 10^{10} \text{ cm}^{-3}$, $\epsilon_s = 11.7\epsilon_0$ and $\epsilon_{ox} = 3.9\epsilon_0$; $\epsilon_0 = 8.85 \times 10^{-14} \text{ C}^2 \text{ N}^{-1} \text{ cm}^{-2}$. (5)

Q7

- a) Derive the expression for induced electric field for a non-uniformly doped n – type semiconductor and the Einstein's relation between diffusion co-efficient and mobility. (5)
- b) The electron concentration in silicon is given by $n(x) = 10^{15} e^{-\left(\frac{x}{L_n}\right)}$ ($x \geq 0$) where $L_n = 10^{-4} \text{ cm}$. The electron diffusion coefficient is $D_n = 25 \text{ cm}^2/\text{s}$. Determine the electron diffusion current density at (i) $x = 10^{-4} \text{ cm}$, (ii) $x = 0$ and (iii) $x \rightarrow \infty$. (5)

Q8

Write short notes on any two of the followings: (5 x 2)

- a) C-V Characteristics of MOS capacitor.
- b) Breakdown mechanism in PN junction.
- c) Complete ionization and freeze-out
- d) JFET and HEMT